

Solid State Physics

$$j_e = -j_h$$

$$j_{full} = 0$$

$$j_e = -\frac{e}{8\pi^3} \int_{\text{occupied}} v(\underline{k}) d^3k$$

← occupied levels

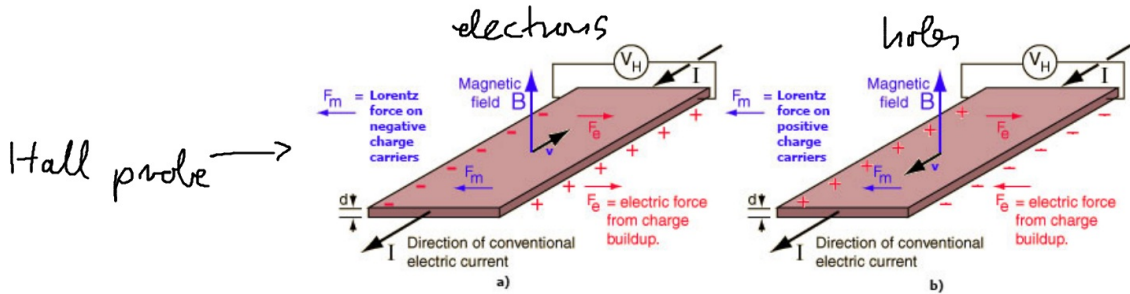
$$j_h = +\frac{e}{8\pi^3} \int_{\text{unoccupied}} v(\underline{k}) d^3k$$

← unoccupied levels

conductors metal

Experimental determination of sign of majority charge carriers: Hall effect

$$\text{magnetic Lorentz force } \underline{F}_m = Q \underline{v} \times \underline{B}$$

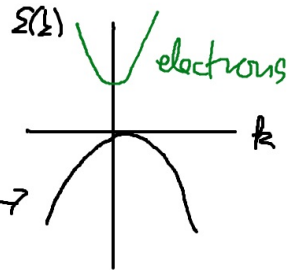
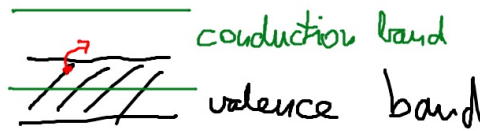


Hall probe →

$$Q = -e$$

$$Q = +e$$

Mg Cd



$$m_{eff} = \frac{1}{\hbar^2} \frac{1}{\left(\frac{d^2 E}{dk^2}\right)}$$

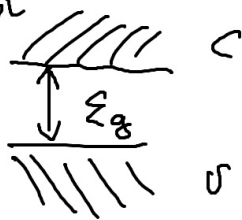
$$v = \mu E \text{ mobility}$$

$$\mu = \frac{e\tau}{m_{eff}}$$

$$E \approx a k^2 + b k + c$$

a larger → m_{eff} smaller
⇒ μ larger

Insulator



$$E_g \gg k_B T$$

$$\approx 6 - 10 eV$$

Diamond $E_g = 5.5 eV$

$$T = 300 K$$

$$k_B T = 0.0258 eV$$

$$e^{-E_g/k_B T}$$

Semiconductors

$$E_g \approx 1 \text{ eV}$$

$$E_g(\text{Si}) = 1.1 \text{ eV}$$

$$E_g(\text{Ge}) = 0.7 \text{ eV}$$

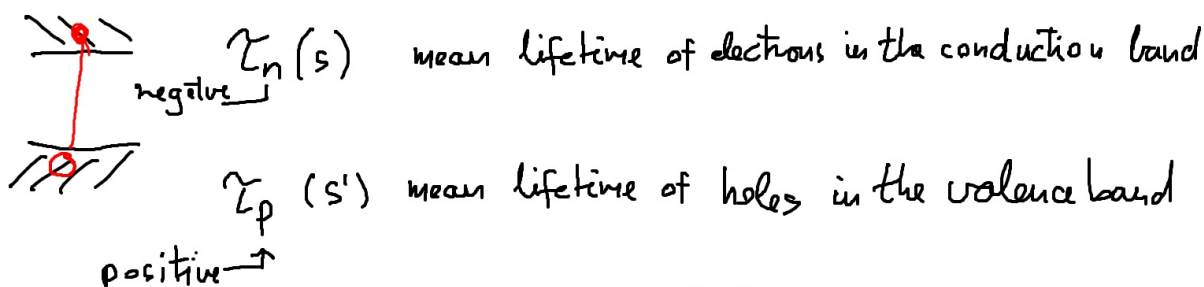
$$\text{Si } \rho(300\text{K}) = 3.32 \cdot 10^{-19} \quad \rho(450\text{K}) = 1.44 \cdot 10^{-6}$$

$$\rho(450\text{K}) / \rho(300\text{K}) \approx \underline{\underline{4 \cdot 10^{12}}}$$

$$\rho_{\text{Si}} \approx 10^{22} \frac{\text{atoms}}{\text{cm}^3}$$

$R_{15} \quad R_{300} \gg R_{450}$ negative thermal coefficients

$R \sim \Delta t$



$$\tau_n(s) = \tau_p(s')$$

electrons $\rightarrow n_c$ \leftarrow density of charge carriers in the conduction band (electrons)

p_v \leftarrow density of charge carriers in the valence band (holes)

$$n_i := n_c = p_v$$

\uparrow intrinsic density of charge carriers

intrinsic semiconductor (not doped)

minority
majority charge carriers

$$\underline{j} = \underline{j}_e + \underline{j}_h$$

cond. b. valence b.

$$\langle \sigma \rangle = M \underline{E}$$

$$\underline{j} = -n_c e \langle \underline{v}_e \rangle + p_v e \langle \underline{v}_h \rangle$$

$$\mu = \frac{+e\tau}{m_{\text{eff}}}$$

$$\underline{j} = n_c e (\mu_e + \mu_h) \underline{E}$$

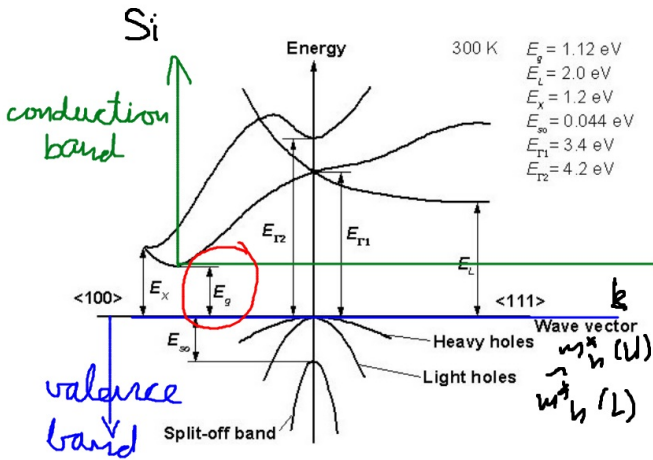
$$\sigma = n_i e (\mu_e + \mu_h)$$

Example: Si $n_i = 1.5 \cdot 10^{16} \frac{1}{\text{m}^3}$ $\mu_e = 0.13 \frac{\text{m}^2}{\text{Vs}}$ $\mu_h = 0.05 \frac{\text{m}^2}{\text{Vs}}$

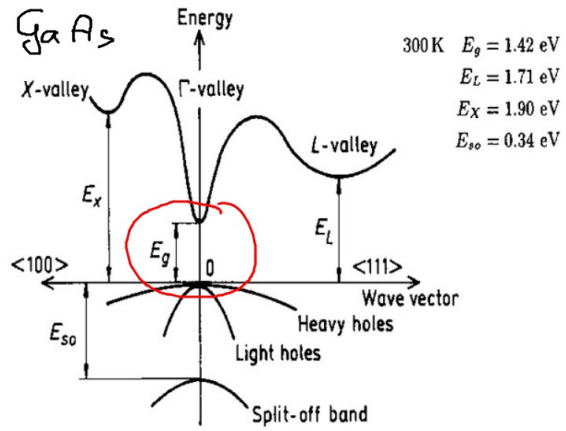
$$\sigma = 1.5 \cdot 10^{16} \cdot 1.6 \cdot 10^{-19} (0.13 + 0.05) = 4.33 \cdot 10^{-4} \frac{1}{\text{m}} \left(\frac{1}{\text{m}^2} \cdot \text{A} \cdot \frac{\text{m}^2}{\text{Vs}} = \frac{1}{\text{V} \cdot \text{m}} \right)$$

$\sigma_{\text{Si}} \approx 10^{-4} \frac{1}{\text{m}}$ $R = ?$ $R = \frac{\rho l}{A} = \frac{l}{\sigma A} = \frac{10^{-2}}{4.33 \cdot 10^{-4} (0.5 \cdot 10^{-3})^2} = 29.4 \text{ M}\Omega$

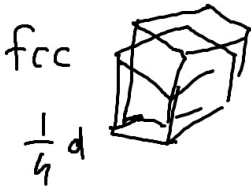
Real band structures:



Si indirect gap semiconductor



GaAs direct gap



$$E_{\text{cond}}(\underline{k}) = E_c + \frac{\hbar^2}{2} \left(\frac{k_1^2}{m_{e1}^*} + \frac{k_2^2}{m_{e1}^*} + \frac{k_3^2}{m_{e2}^*} \right)$$

* \rightarrow effective mass e-electron



$$E_{\text{valenc}}(\underline{k}) = E_v - \frac{\hbar^2}{2} \left(\frac{k_1^2}{m_{h1}^*} + \frac{k_2^2}{m_{h1}^*} + \frac{k_3^2}{m_{h2}^*} \right)$$

pot. box $V_0 = \text{const}$
 $V(x) = \begin{cases} 0 & \text{inside} \\ \infty & \text{outside} \end{cases}$
 E

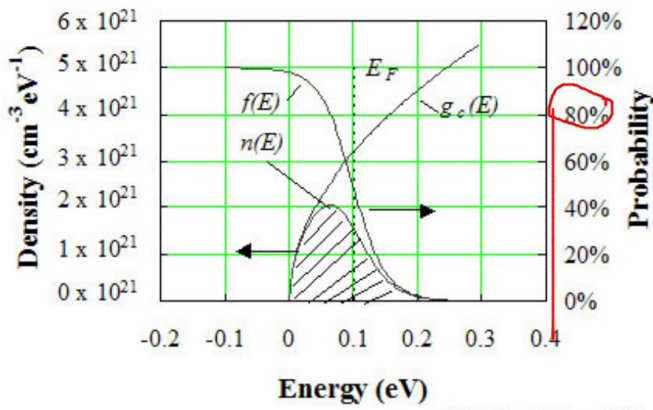
intrinsic semiconductor

conduction electrons $V_0 = E_c \quad E \Rightarrow E - E_c > 0$
 holes $V_0 = E_v \quad E \Rightarrow E_v - E > 0$

electrons		Si	Ge
longitudinal	m_l/m_e	0.98	1.59
transverse	m_t/m_e	0.19	0.0815
dens.of.states	m_c/m_e	0.36	0.22
for conduct.	m_{cc}/m_e	0.26	0.12 $\leftarrow m_e$
holes		Si	Ge
heavy	m_h/m_e	0.49	0.33
light	m_{lp}/m_e	0.16	0.043
split-off band	m_{so}/m_e	0.24	0.084
dens.of.states	m_v/m_e	0.81	0.34 $\leftarrow m_h$

$$g_c(E) = \frac{8\pi\sqrt{2}m_p^3}{\hbar^3} \sqrt{E - E_c} \quad E \geq E_c$$

$$g_v(E) = \frac{8\pi\sqrt{2}m_n^3}{\hbar^3} \sqrt{E_v - E} \quad E \leq E_v$$



$$n(E) = f(E) g_c(E)$$

$$\langle \sigma \rangle = \int_0^{\infty} \sigma(E) f_{F-D}(E) g(E) dE$$

$$\text{for } n \quad \sigma \equiv 1$$

cond. band $f_{F-D}^{(electrons)} = \frac{1}{e^{(E-E_F)/k_B T} + 1}$

valence band $f_{F-D}^{(holes)} = 1 - f_{F-D}^{(electrons)}$

$$f_{F-D}^{(holes)} = 1 - \frac{1}{e^{(E-E_F)/k_B T} + 1} = \frac{e^{(E-E_F)/k_B T} + 1 - 1}{e^{(E-E_F)/k_B T} + 1} = \frac{1}{e^{-(E-E_F)/k_B T} + 1}$$

$$n_c(T) = \int_{E_c}^{\infty} g_c(E) \frac{dE}{e^{(E-E_F)/k_B T} + 1}$$

$$p_v(T) = \int_{-\infty}^{E_v} g_v(E) \frac{1}{e^{-(E-E_F)/k_B T} + 1} dE$$

[IF] non-degenerate semiconductor ($E_g \gg 3k_B T$)

$$n_c(T) = N_c e^{-(E_c - E_F)/k_B T}$$

$$p_v(T) = P_v e^{-(E_F - E_v)/k_B T}$$

where $N_c(T) = 2.5 \cdot 10^{19} \left(\frac{m_c^*}{m_e}\right)^{3/2} \left(\frac{T}{300K}\right)^{3/2}$

$$P_v(T) = 2.5 \cdot 10^{19} \left(\frac{m_v^*}{m_e}\right)^{3/2} \left(\frac{T}{300K}\right)^{3/2} \quad (*)$$

example

	Si	Ge
m_e^*/m_e	0.36	0.22
m_h^*/m_h	0.81	0.34
$N_c(300K)$	$2.81 \cdot 10^{19}$	$1.02 \cdot 10^{19}$
$P_v(300K)$	$1.83 \cdot 10^{19}$	$5.64 \cdot 10^{18}$

true for all semiconductors

$$n_i^2 = n_c \cdot p_v = N_c P_v e^{-(E_c - E_v)/k_B T} = N_c P_v e^{-E_g/k_B T}$$



mass-action law for semiconductors

only true for intrinsic semic

$$N_c(T) e^{-\frac{(E_c - E_F)}{k_B T}} = P_v(T) e^{-\frac{E_F - E_v}{k_B T}} \Rightarrow \frac{N_c(T)}{P_v(T)} = e^{-\frac{E_F - E_v + E_F - E_c}{k_B T}}$$

$$-2E_F + (E_c + E_v) = k_B T \cdot \frac{N_c(T)}{P_v(T)}$$

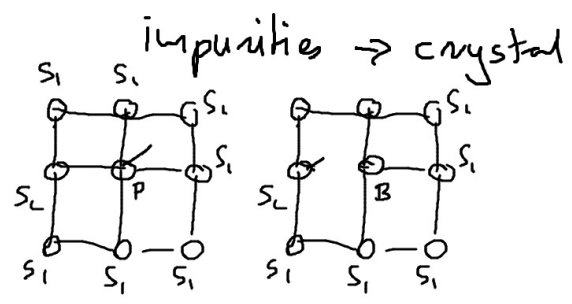
$$E_F = \frac{1}{2} (E_c + E_v) + \frac{1}{2} k_B T \ln \left(\frac{P_v}{N_c} \right)$$

from *

$$E_F = E_G + \frac{1}{2} E_g + \frac{3}{4} k_B T \ln \left(\frac{m_h^*}{m_e^*} \right)$$

i) $m_h^* = m_e^* \Rightarrow E_F = E_G + \frac{1}{2} E_g$ in the middle of E_g
usually taken to 0

Extrinsic semiconductors



Group IV	semicond.
Si, Ge	4
Group III	B
Group V	P

Ionization energy:

(H) in vacuum

$$E_{100}^{(H)} = \frac{e^4 m_e^2}{32 \pi^2 \epsilon_0^2 \hbar^2} \cdot \frac{1}{12} = \frac{e^4}{32 \pi^2 \hbar^2} \frac{m_e^2}{\epsilon_0^2} = 13.6 \text{ eV}$$

$$r_{Bdm} = \frac{4 \pi \epsilon_0 \hbar^2}{m_e e^2} = \frac{4 \pi \hbar^2}{e^2} \frac{\epsilon_0}{m_e} = 0.0529 \text{ nm}$$

in a material with m_e^* and relative permittivity ϵ_r

$$E_{100} = 13.6 \text{ eV} \cdot \frac{m_e^*}{m_e} \cdot \frac{1}{\epsilon_r^2}$$

$$r_0 = r_{Bdm} \cdot \frac{m_e}{m_e^*} \epsilon_r$$

Example Si: $\epsilon_r = 11.7 \rightarrow E \approx 12.6 \cdot 0.26 / 11.7^2 = 0.0258 \text{ eV}$

$$m^* = m_{cc} = 0.26 m_e$$

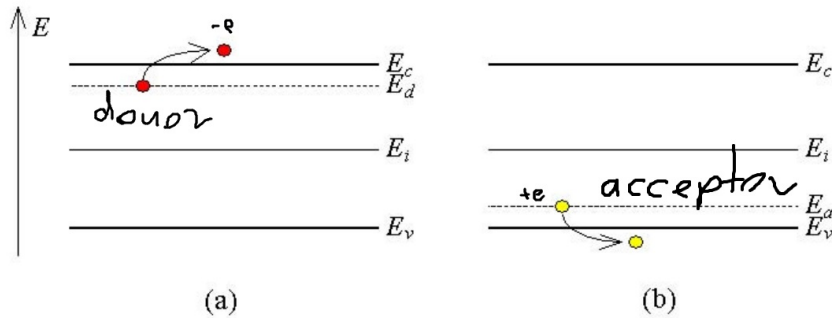
$$r_0 = r_{Bohr} \cdot \frac{11.7}{0.26} = 2.38 \text{ nm}$$

How many electrons from donor atoms are excited?

$$D = E_n E_o E$$

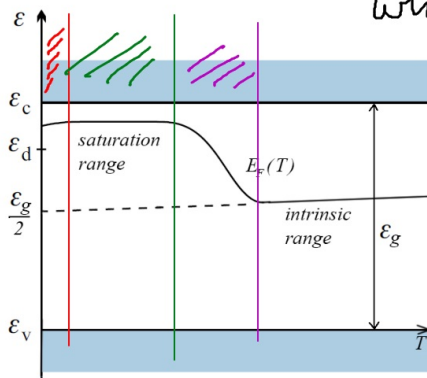
Concl. $E_c - E_p = 0.0258 \text{ eV}$

E_c $E_g = 1.1 \text{ eV}$ E_v valence $k_B T (300K) = 0.0258 \text{ eV} \Rightarrow 36.8\% \text{ ionized}$
in intrinsic Si only $3 \cdot 10^{-17}\%$!



$$E_F(T) ?$$

from Nd
all ionized
from valence
band too



What is E_F here? metals: at 0K all levels below it is occupied above it empty

Semiconductors / Insulators: defined by E_c, E_v and E_F and $g(E)$

doped semiconductors

extrinsic semic.

crystal neutral: $\sum Q = 0$ $\sum Q = \underbrace{N^+ + p_v}_{+} - \underbrace{N^- + n_c}_{-} = 0$

n-type the electrons are the majority charge carriers
p-type the holes

$$n_c, p_v \quad n_c \neq n_i \quad p_v \neq n_i$$

mass-action law for semiconductors

n-type $n_c \approx N_d - N_A$

p-type $p_v \approx N_A - N_D$

$$n_c \cdot p_v = n_i^2$$